

PATENT APPLICATION Docket No. 11675.114 HID B

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re application of: | |) #\W |
|-----------------------|--|------------|
| | Kei-Yu Ko |) Art Unit |
| Serial No.: | 08/846,671 |) 1765 |
| Filed: | April 30, 1997 | 70 |
| For: | UNDOPED SILICON DIOXIDE AS ETCH STOP FOR SELECTIVE ETCH OF DOPED SILICON DIOXIDE | RECEIVE |
| Examiner: | George A. Goudreau | E ROOM |
| | AMENDMENT BUNDER 37 C F R & 1 111 | 2 |

The Honorable Commissioner of Patents and Trademarks Washington, D. C. 20231

Sir:

In response to the Office Action mailed on February 17, 2000 (the "Office Action"), the Applicants submit this Amendment A and response.

IN THE CLAIMS

Amend Claims 1, 9, 13, 15, 18-23, 26, 30-34, 37, 39, 41-42, 44- 45, 50, and 53 as follows: